

ABSTRACT

An in-plane switching mode LCD device and a method for manufacturing the same are disclosed, which are applicable to LCD device having a wide viewing angle, fineness and a wide size by using low resistance materials as source and drain electrode. A buffer layer is
5 formed on an ohmic contact layer in the in-plane switching mode LCD.

Figure 1 consists of 12 sub-graphs labeled (a) through (l). Each graph plots the concentration of *E. coli* O157:H7 in log₁₀ CFU/g on the y-axis (ranging from 0 to 10) against time in hours on the x-axis (ranging from 0 to 24). The graphs show various growth curves, with some showing a decrease in CFU over time, indicating inhibition of growth. The treatments represented are: (a) Control, (b) 0.1% NaOCl, (c) 0.5% NaOCl, (d) 1.0% NaOCl, (e) 2.0% NaOCl, (f) 4.0% NaOCl, (g) 8.0% NaOCl, (h) 16.0% NaOCl, (i) 32.0% NaOCl, (j) 64.0% NaOCl, (k) 128.0% NaOCl, and (l) 256.0% NaOCl.